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FASSE PATENT ATTYS

PAGE 01/02

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BY TELEFAX 703-746-9195

DOCKET NO.: 4887

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF THE APPLICATION FOR PATENT

OF: Makoto OTSUKI et al. | ART UNIT: 2812
SERIAL NO.: 10/537,529 | CONF. NO.: 4558
FILED: June 3, 2005
FOR: METHOD OF MANUFACTURING SINGLE-CRYSTAL SEMICONDUCTOR WAFERS
AND LASER MACHINING APPARATUS THEREFOR

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October 27, 2005

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- 1) The Official Filing Receipt contains errors. Please correct the following items as shown on the enclosed marked-up copy of the Filing Receipt:
 - Assignment for Published Patent Application
 - Title
- 2) The requested corrections are supported by the application transmittal letter and the specification as filed on June 3, 2005. *(see the bottom of page 1 thereof)*
- 3) Please issue a corrected Filing Receipt.

Respectfully submitted,
Makoto OTSUKI et al.-Applicant

By Walter Fasse
W. F. Fasse - Patent Attorney
Reg. No.: 36132
Tel: 207 862 4671
Fax: 207 862 4681
P.O. Box 726, Hampden, ME 04444-0726

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Enclosure:
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I hereby certify that this correspondence with all indicated enclosures is being transmitted by telefax to 703-746-9195 on the date indicated below, and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Karin Smith - October 27, 2005
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CONFIRMATION NO. 4558

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P.O. BOX 726
HAMPDEN, ME 04444-0726

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Applicant(s)

Makoto Otsuki, Itami-shi, JAPAN;
Masayuki Nishikawa, Itami-shi, JAPAN;
Yasuyuki Matsui, Itami-shi, JAPAN;

~~X~~ Assignment for Published Patent Application
Sumitomo Electric Industries, Ltd., Osaka-shi, JAPAN ~~X~~

Power of Attorney: The patent practitioners associated with Customer Number 21553.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/08108 06/10/2004

Foreign Applications

JAPAN 2003-176746 06/20/2003

Projected Publication Date: 01/05/2006

Non-Publication Request: No

Early Publication Request: No

~~X~~ Title Method of manufacturing single-crystal semiconductor wafers
-Method of producing semiconductor single-crystal wafer and laser processing device used
-therefor and laser machining apparatus therefor ~~X~~